	Application No.	Applicant(s)	(h) (V
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Notice of Allowability	10/016,300 Examiner	TZU ET AL. Art Unit	
	Rudy Zervigon	1763	
The MAILING DATE of this communication a All claims being allowable, PROSECUTION ON THE MERITS herewith (or previously mailed), a Notice of Allowance (PTOL- NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATEN of the Office or upon petition by the applicant. See 37 CFR 1.	ppears on the cover sheet w S IS (OR REMAINS) CLOSED i 85) or other appropriate comm T RIGHTS. This application is	ith the correspondence add n this application. If not include unication will be mailed in due	ded e course. THIS
1. $igtimes$ This communication is responsive to <u>the request for Co</u>	ontinued Examination Under 37	<u>CFR 1.114</u> .	
2. $igotimes$ The allowed claim(s) is/are $\underbrace{3\text{-}6,20\text{-}23,29\text{-}33,37\text{-}41}$ and	<u>52-56</u> .		
3. $igotimes$ The drawings filed on <u>25 September 2003</u> are accepte	d by the Examiner.		
 4. Acknowledgment is made of a claim for foreign prioriting a) All b) Some* c) None of the: 1. Certified copies of the priority documents by the copies of the priority documents by the copies of the priority documents by the certified copies of the priority local lateral (PCT Rule 17.2(a)). * Certified copies not received: 	nave been received. nave been received in Applicati	on No	ation from the
Applicant has THREE MONTHS FROM THE "MAILING DA' noted below. Failure to timely comply will result in ABANDO THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	TE" of this communication to fil DNMENT of this application.	e a reply complying with the re	equirements
 A SUBSTITUTE OATH OR DECLARATION must be sum informal patent application (PTO-152) which 			NOTICE OF
 CORRECTED DRAWINGS (as "replacement sheets") (a) including changes required by the Notice of Drafts 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Exami Paper No./Mail Date (b) Heattached Exami Paper No./Mail Date (b) Heattached Exami Deach sheet. Replacement as the application number (see 37 Cleach sheet. Replacement sheet(s) should be labeled as such DEPOSIT OF and/or INFORMATION about the deattached Examiner's comment regarding REQUIREMENT. 	person's Patent Drawing Revie ner's Amendment / Comment of FR 1.84(c)) should be written on in the header according to 37 Ce eposit of BIOLOGICAL MAT	or in the Office action of the drawings in the front (not the FR 1.121(d). ERIAL must be submitted.	
Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-94) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/5 Paper No./Mail Date 5/12/2004 4. ☐ Examiner's Comment Regarding Requirement for Depo of Biological Material	6. Interview S Paper No SB/08), 7. Examiner's	nformal Patent Application (Presummary (PTO-413), ./Mail Date s Amendment/Comment s Statement of Reasons for Al	

Application/Control Number: 10/016,300

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DETAILED ACTION

Continued Examination Under 37 CFR 1.114

1. A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on February 17, and May 12, 2004 have been entered.

Allowable Subject Matter

- 2. Claims 3-6, 20-23, 29-33, 37-41, and 52-56 are allowed.
- The following is a statement of reasons for the indication of allowable subject matter: The closest prior art references to the present invention is to Conger et al (USPat. 4,761,269), Hao et al (USPat. 6,123,775), Tomita et al (USPat. 5,423,936), and copending Application No. 09/798,258. Conger, for example, teaches a lid assembly (16; Figure 2; column 5, line 54 column 6, line 26; Compare applicant's lid 20; Figure 2) for a semiconductor processing system (column 1, lines 10-15). Refer to prior office actions for additional claim limitations.

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Currently, all amended independent claims 3, 22, and 31 now recite a gas "reservoir positioned on the lid". The closest prior art reference to Conger teaches a reservoir (56; Figure 1) coupled to the valves 22a,b; Figure 2. Yet, as shown by Conger, his reservoir is not positioned on his lid. None of the other prior art references teach or suggest such a gas reservoir positioned on the lid as claimed by independent claims 3, 22, and 31.

Newly added claims 52-56 are allowable for the same reasons independent claims 3, 22, and 31 are allowable. Specifically, new independent claim 52 recites "a gas control system disposed on the first surface" of the lid "the gas control system comprises: ... a gas manifold disposed on the lid...at least one precursor reservoir fluidly connected between at least one precursor source and the gas manifold". New independent claim 54 recites "a gas control system disposed on the first surface" of the lid "the gas control system comprises: ... a gas manifold disposed on the lid...at least one precursor reservoir fluidly connected to the gas manifold".

Conclusion

4. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Examiner Rudy Zervigon whose telephone number is (571) 272.1442. The examiner can normally be reached on a Monday through Thursday schedule from 8am through 7pm. The official fax phone number for the 1763 art unit is (703) 872-9306. Any Inquiry of a general nature or relating to the status of this application or proceeding should be directed to the Chemical and Materials Engineering art unit receptionist at (571) 272-1700. If the examiner can not be reached please contact the examiner's supervisor, Gregory L. Mills, at (571) 272-1439.